

a-Si film fomed by CVD method

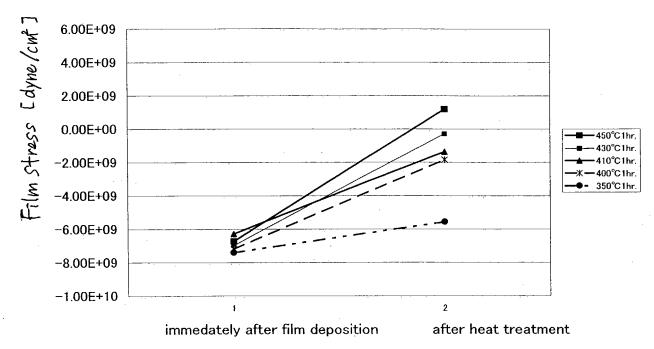


Fig. 2

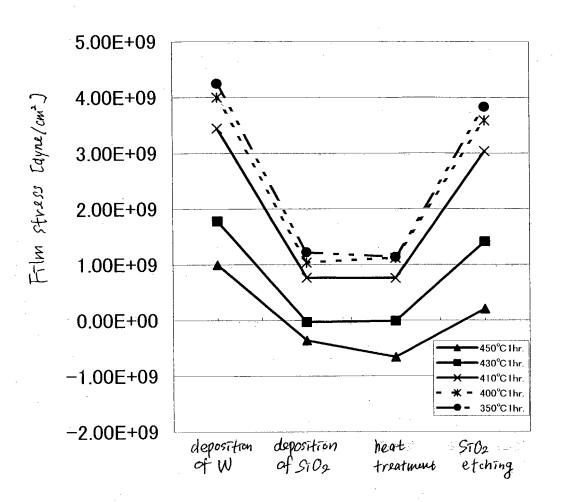
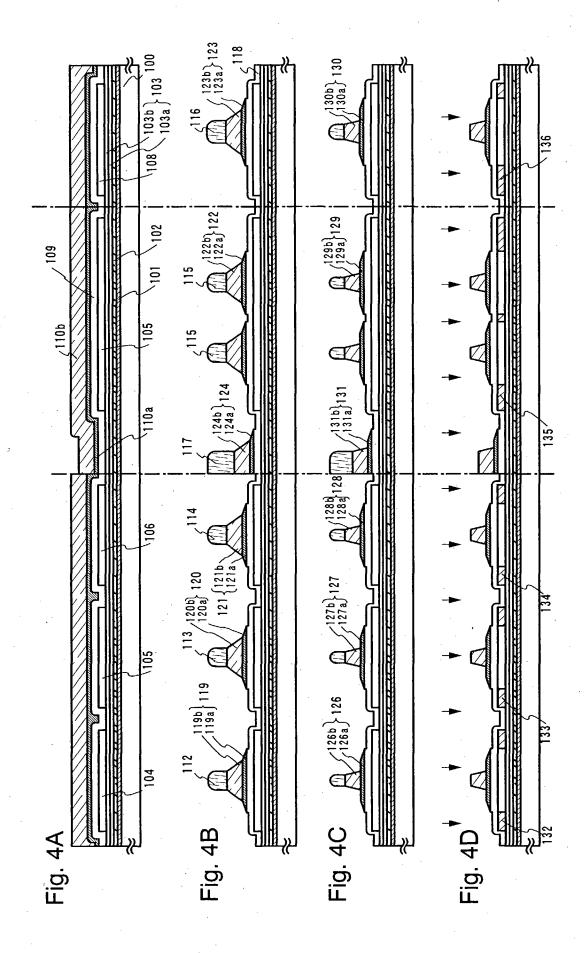
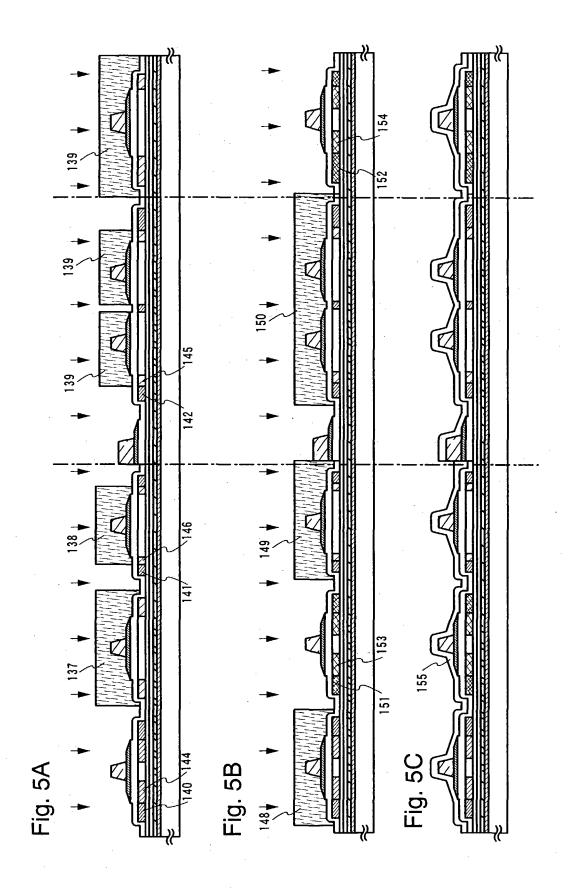
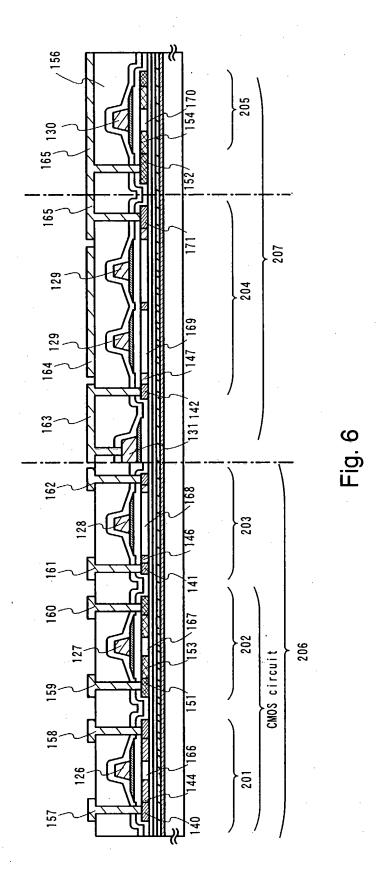


Fig. 3







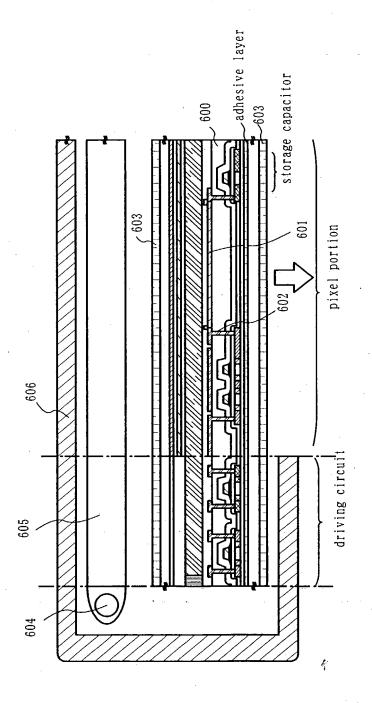


Fig. 7

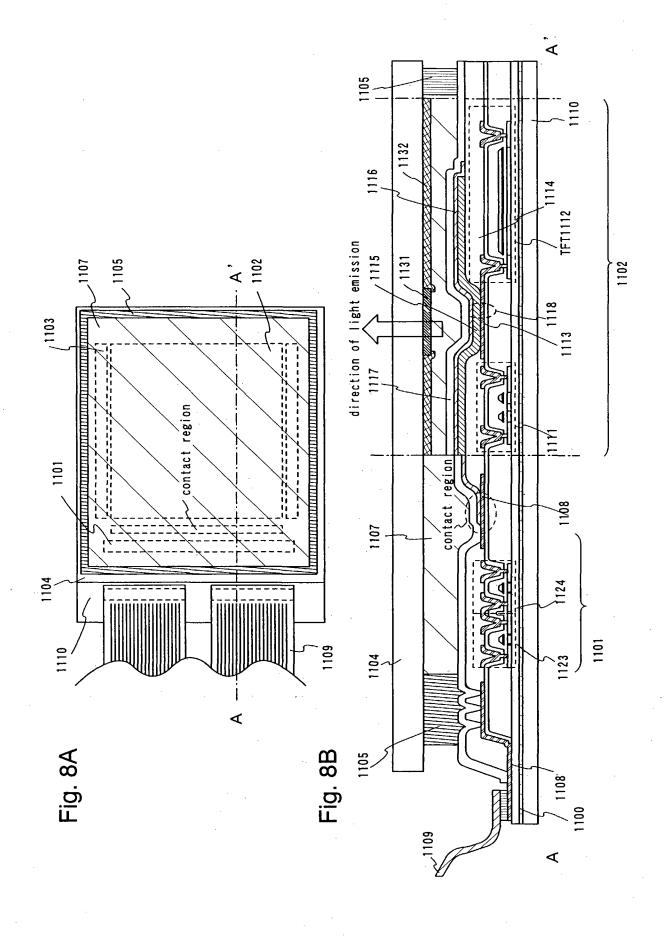


Fig. 9B Fig. 9A Fig. 9C Fig. 9D Fig. 9E

